

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10626675
<b>Filing Date:</b>	25-Jul-2003
<b>Title of Invention:</b>	Epitaxial wafer production apparatus and susceptor structure
<b>First Named Inventor/Applicant Name:</b>	Hidemasa Kai
<b>Filer:</b>	Darrin A. Auito/Robin Rothwell
<b>Attorney Docket Number:</b>	030901

Filed as Large Entity

### **Utility under 35 USC 111(a) Filing Fees**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
<b>Extension-of-Time:</b>				
Extension - 2 months with \$120 paid	1252	1	370	370

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
Request for continued examination	1801	1	810	810
<b>Total in USD (\$)</b>				<b>1180</b>